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| PTO/SB/08A | | Complete if Known | |
| SEVENTH SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary) OCT 28 2003 | | Application Number | 09/607,535 |
| | | Filing Date | June 29, 2000 |
| | | Confirmation Number | 8642 |
| | | First Named Inventor | Shenheng Guan, et al. |
| | | Group Art Unit | 1743 |
| | | Examiner Name | Dwayne K. Handy |
| Sheet 1 of 1 | Attorney Docket No. | SMX 3161.1 (98-13DIV1) | |

| U.S. PATENT DOCUMENTS | | | | | |
|-----------------------|--------------------------|----------------------|--------------------------------------|--|--|
| Examiner Initials* | Cite No. ¹ | U.S. Patent Document | | Name of Patentee or Applicant of Cited Document | Date of Publication of Cited Document MM-DD-YYYY |
| | | Number | Kind Code ² (if known) | | |
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| Examiner Initials* | Cite No. ¹ | Foreign Patent Document | | | Name of Patentee or Applicant of Cited Document | Date of Publication of Cited Document MM-DD-YYYY | T ⁶ |
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| DKM | 61. | "Nanoflowreactor nu in zesvoud uitgevoerd!", LabSpiegel, September 23, 1988, Royal/Shell Laboratory, Amsterdam | ✓ |
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| Examiner Signature | Dwayne K. Handy | Date Considered | 12/18/03 |
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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